Research Article

Alumina Template-Dependant Growth of Cobalt Nanowire Arrays

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Different electrochemical regimes and porous alumina were applied for template synthesis of cobalt nanowire (nw) arrays, revealing several peculiar cases. In contrast to quite uniform filling of sulfuric acid alumina templates by alternating current deposition, nonuniform growth of the Co nw tufts and mushrooms was obtained for the case of oxalic acid templates. We showed herein for the first time that such configurations arise from the spontaneous growth of cobalt nw groups evolving from the cobalt balls at the Al/alumina interface. Nevertheless, the uniform growth of densely packed cobalt nw arrays, up to tens of micrometers in length, was obtained via long-term direct current galvanostatic deposition at low current density using oxalic acid templates one-side coated by conducting layer. The unique point of this regime is the formation of hexagonal lattice Co nwS with a preferred (100) growth direction.

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1. Introduction

Cobalt nanowires (nwS) and nanoparticles, produced with controllable nanodimensions and spacing, organized into ordered arrays, attract great interest for their enhanced vertical magnetic anisotropy [1], catalytic properties for carbon nanotubes synthesis [2], high specific heating power [3], and thus becoming the promising material for fabrication of magnetic superstructures and C60-based devices and for applications in the therapy of tumors.

To date, various mesoporous materials such as nanochannel glasses [4], perforated polycarbonate membranes [5], anodic oxide films of aluminum [6], carbon nanotubes [7], and organic molecule networks [8] have been employed as templates for the fabrication of arrays of various materials by means of electroless, sol-gel, hydrothermal, solvothermal, chemical vapor, and electrodeposition approaches.

Porous anodic oxide films of high-purity aluminum are likely the most widely applied templates for preparation of highly ordered nw and nanotube arrays of metals [9–11], semiconductors [12–15], and conducting polymers [16] with well-defined product dimensions at packing density of $10^9–10^{11}$ species/cm$^2$. It is generally accepted that the diameter and density of tube-shaped pores, arranged in the central part of alumina hexagonal cells, can be simply controlled by varying the anodizing voltage of aluminum, while the length of pores, by anodizing time, adjusts some tens of micrometers. There is always a high-resistance barrier layer between the bottom of the alumina pores and aluminum, whose thickness is proportional to the anodizing voltage (usually in the range 1.0–1.2 nm/V) [17, 18]. This barrier layer prevents continuous supply of electrons to the bottom of pores, restricting the effectiveness of electrochemical methods for uniform synthesis of nw arrays.

To remove this thin layer or perforate it, at the bottom of alumina nanochannels, various etching solutions [19–21] and different methods [22] have been applied during the last decade. These procedures usually require the detachment of the alumina film from the aluminum substrate, which can be applied only to “thick” alumina templates. Furthermore, the thermal sputtering of gold [23, 24], silver [25], or platinum [26] layer onto the back-side of perforated template as a conducting and well-adhesive layer is crucial once one aims at filling the alumina nanochannels by direct current (DC) deposition.

On the other hand, there always exists the possibility of filling alumina pores by alternating current (AC) regimes,
leaving intact the barrier layer at the bottom of the pores. According to some opinions [27], AC electrolysis is an ideal method for deposition of metal and semiconductor nws, starting from the bottom of pores. However, different groups using this method [28, 29] have recently observed interrupted growth of various polycrystalline materials and just partial depositions, namely, only in a fraction of pores. In our work, we found that the growth of cobalt nws depends much stronger on conditions for fabricating the alumina template than other metals like copper, silver, or tin. For example, only sulfuric acid alumina templates can be successfully filled by Co nws using AC, while the use of the same deposition solution for uniform growth of Co nws in oxalic or phosphoric acid alumina pores is problematic. However, the effects of the template-dependant metal nws growth by electrodeposition are not pronounced. Therefore, in this study we focus on the investigation of the peculiarities of the Co nws electrochemical growth using oxalic and sulfuric acid alumina templates at different regimes.

Three approaches for cobalt nws synthesis within the alumina pores were studied and discussed herein:

(i) AC deposition in the as-grown templates,
(ii) AC and DC deposition through a reconstructed barrier layer,
(iii) DC galvanostatic deposition after perforation or detachment of the barrier layer and subsequent evaporation of a metallic layer as a conductive pad.

2. Experimental

2.1. Preparation of Alumina Templates. Experiments were carried out using 99.685 at % (Russia) and 99.99 at % purity (Goodfellow Ltd.) aluminum foils, from which specimens of dimensions $50 \times 50$ and $15 \times 15$ mm$^2$ were, respectively, cut. The surface of specimens was chemically cleaned in the usual manner. The anodization of specimens was carried out using aqueous solution of sulfuric acid (either 1.5 M; $18 \pm 0.01^\circ$C; 15 V or 0.5 M; $3 \pm 0.01^\circ$C; 25 V) or oxalic acid (0.3 M, $17 \pm 0.01^\circ$C; 40 V) for a period of 0.5–5.0 hours, with a vigorous stirring. Two lead sheets and graphite stripes were used as cathodes in sulfuric and oxalic acid anodizing baths, respectively. Under these conditions ordered alumina templates 3.5 to 50 $\mu$m thick, were obtained. In sulfuric acid, at 15 and 25 V of anodizing voltage, the average pore diameters ($O_{pore}$) were 15 nm and 28 nm with pitch spacing of 43 and 65 nm, respectively. In oxalic acid a $O_{pore}$ of 40 nm with 108 nm pitch spacing was obtained.

In order to improve AC and DC deposition, reconstructed (modified) barrier layers were obtained. In particular, AC deposition improves using a thinner layer, while DC deposition is possible only through a perforated barrier layer. Such reconstructed barrier layers were obtained by using both electrochemical and chemical methods. In the electrochemical posttreatment, the anodizing voltage was decreased at the end of anodization process, through a step-wise procedure from 3 to 0.5 V/min until the final voltage ranges from 15.0 to 5.0 V. To widen the pores as well as to dissolve the barrier layer, a solution of either 0.5 M H$_3$PO$_4$ or 2 M H$_2$SO$_4$ both kept at 30 $^\circ$C for up to 45 minutes time ($t_{ev}$) was applied. To detach the alumina template from the substrate, one-side etching procedures of the electrode window first in NaOH and then in 0.1 M CuCl$_2$ + 10 % HCl were used.

The conductive layer on the back side of perforated alumina templates was obtained by evaporating a 100 nm thick Cr layer followed by a 150 nm thick Au layer, using an Edwards E306A thermal evaporator, with a source-to-sample distance of 20 cm.

2.2. Electrochemistry of the Metal Array Fabrication. For growing cobalt nws into alumina nanochannels, a solution, composed of $\text{cos O}_4$, $\text{H}_2\text{BO}_3$, $\text{MgSO}_4$, $\text{H}_2\text{SO}_4$, and triethanolamine, $\text{N(C}_2\text{H}_4\text{OH})_3$ (TEA), was optimized. Analytical grade salts used for preparation of solutions were purchased from Aldrich. All solutions were prepared using Milli-Q water and high purity acids. Co nws inside the alumina pores were grown in thermostated electrochemical cells configured for two or three electrodes for AC and DC electrolysis, respectively. A graphite stripe was used throughout all deposition experiments as a counter electrode, and a silver/silver chloride electrode connected to the cell through the salt/agar-agar bridge was used as a reference. Electrodepositions of cobalt nws within the alumina pores by DC electrolysis were conducted via potentiostatic and galvanostatic mode for up to 300 minutes. The electrochemical apparatus included a programmable potentiostat/galvanostat PI-50-I. Furthermore, to investigate effects on the Co nws growth for a maximum 1.5 hour, a function generator (FLUKE PM5138A) was used to supply AC sine wave voltage within the frequency range of 10–1000 Hz at a fixed peak to peak voltage and a cryostatic

![Figure 1: Variation of the amount of Co ($m_{Co}$) inside the alumina pores for the deposition solution made of 0.2 $\text{cos O}_4$, 0.7 $\text{H}_2\text{BO}_3$, 0.01 M $\text{MgSO}_4$, and TEA up to pH 5.7, at constant AC voltage $U_{F-p}$ of 32 V, 50 Hz and 20 $^\circ$C, as a function of the deposition time. $O_{pore}$ 15 nm; template thickness ($h_{AAO}$) 15 $\mu$m. In the inset, variation of $m_{Co}$ versus AC frequency ($f$) for the same deposition solution and $U_{F-p}$ value for 15 minutes of deposition.](image-url)
system to keep constant the bath temperature fixed in the range of 5–50°C. Again, for depositions at AC frequency of 50 Hz under constant effective current density ($j_{ac}$) control in the range 0.2–0.65 A dm$^{-2}$, a custom made generator was used.

2.3. Characterization. Nanostructured products deposited within the alumina pores were characterized using a scanning electron microscope (SEM, Philips 30 L) and a field emission scanning electron (FESEM, LEO 1530, equipped with an Oxford Instruments INCA PentaFET-X3 EDS detector) microscopes under typical working conditions. For freestanding metal array fabrication, the template was partially or fully dissolved by dipping into 0.5 M H$_3$PO$_4$ for (a) 30, (b) 70 and (c) 100 minutes.

**Figure 3:** Top view FESEM images for fragments of Co NW arrays fabricated under the optimized AC deposition conditions in the sulfuric acid alumina template pores after the template etching in 0.5 M H$_3$PO$_4$ for (a) 30, (b) 70 and (c) 100 minutes.
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Figure 4: Typical top view SEM images of Co “mushroom” grown by AC treatment of oxalic acid alumina template in the solution of this study. Before deposition the thickness of alumina barrier layer was reduced by lowering the anodizing voltage \( U_a \) down to final value \( U_{a, \text{fin}} \) equal to 15 V.

Figure 5: Top view FESEM image for fragments of Co nanowires fabricated in the oxalic acid alumina pores by AC (50 Hz) deposition from the optimized solution at \( j_{ac} \sim 0.5 \text{ A dm}^{-2} \) \( (U_p - p \text{ from 18 to 32 V}) \) and room temperature for (a) 10 and (b) 20 minutes. Before depositions, the barrier layer of the as-grown templates was thinned by decreasing anodizing voltage down to 20 V and etching in 0.5 M H$_3$PO$_4$ at 30 °C for 32 minutes. Following depositions the template was etched in the same 0.5 M H$_3$PO$_4$ solution.

2.4. Analysis. Before analyzing the deposited cobalt, in order to remove the residual ions entrapped in the alumina template, the specimens were thoroughly rinsed and soaked in deionized water for about 10 minutes. The amount of cobalt was determined after the complete dissolution of Co$^0$ nanowires from 8.0 cm$^2$ template surface in a mixture of hydrogen peroxide (25%) and nitric acid (1 : 8 v/v). All solutions used for nanowires dissolution, sample rinsing, and further double soaking in deionized water for 10 minutes were collected together, diluted to constant volume up to 100 mL, and analyzed quantitatively using a computer-controlled Perkin Elmer Lambda 35 UV/Vis spectrophotometer. To increase absorbance detection sensitivity of cobalt analyte at 520 nm, Nitroso-R-salt solution was used as a complexing agent. Reproducibility of the analysis was checked with 3 repeated experiments. Standard solutions were made from 99.999 at % grade cobalt. A linear Beer-Lambert law calibration curve of cobalt absorbance versus ppm was obtained using a series of standard concentrations between 3 and 60. The concentration of unknown cobalt was calculated using a typical calibration graph.

3. Results and Discussion

3.1. The Composition of the Deposition Solution. One parameters we were able to easily control is the composition of deposition electrolyte. In this study, the composition of solution for Co nanowires electrosynthesis within the alumina pores was organized using cos O$_4$, as a precursor for cobalt ions and H$_3$BO$_3$, a buffering ingredient to prevent any pH variation within the alumina pores and to inhibit the formation of cobalt hydroxide species as a result of hydrogen evolution [30]. Furthermore, MgSO$_4$ was added as Mg$^{2+}$ source to prevent the breakdown of alumina barrier layer [31] during AC depositions. To adjust the pH of solutions, H$_2$SO$_4$ and triethanolamine (TEA) 1 : 1 solutions in water were used. From a review of patent’s literature [32], it arises that these components have been frequently used for AC coloring of anodized aluminum in the Co$^{2+}$-containing baths. To optimize the concentration of components and the solution pH, 15 μm thick sulfuric acid alumina templates were used. All depositions in this setup were performed using 50 cm$^2$ specimens, a 50 Hz frequency AC and constant peak-to-peak voltage of 32 V, for 15 minutes. Observation of the alumina color uniformity and the amount of deposited cobalt were the main criteria adopted in the search of the optimal composition. Consequently, the solution composed of 0.2–0.25 M cos O$_4$, 0.65–0.7 M H$_3$BO$_3$, 0.005–0.05 M MgSO$_4$ and TEA, to adjust a pH at 5.5–5.75, was determined as optimum for AC filling of alumina templates with Co nanowires.
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15 kV ×1000 10 μm (a)

100 kV ×9600 1 μm (b)

JL93-B3-NaOH-10 s 20 kV ×1000 10 μm (c)

S Al Co C 0 1234 (d)

Figure 6: SEM images of reconstructed oxalic acid alumina templates after deposition of Co nws by AC treatment in the solution as in Figure 1 at $U_{p-p}$ 32 V and room temperature for 20 minutes. $h_{AAO}$ 13 μm, $\Phi_{pore} \sim 45$ nm, $t_{w}$ 30 minutes in 0.5 M H$_3$PO$_4$. (a) top-side view after dissolution some part of alumina; (b) in plane view; (c) cross-sectional view. (d) EDX spectrum of specimen.

3.2. AC Deposition into As-Grown Templates. Figure 1 demonstrates typical variation of the amount of Co assembled inside the alumina pores ($m_{Co}$) with the deposition time and AC current frequency ($f$) used for depositions. As seen, the amount of deposited Co increases linearly during the first 10–20 minutes of AC treatment at constant voltage. However, with further processing the rate of deposition inside the alumina pores progressively decreases. Moreover, it was observed that this solution allows the growth of cobalt nws within a wide range of AC frequencies, ca. from 10 to 200 Hz, coloring the template uniformly from bronze to deep black. A further increase in frequency, up to 1000 Hz, results in a smaller amount of deposited cobalt and therefore in a lighter template color intensity. As seen from the inset of Figure 1, the maximum amount of cobalt can be deposited using 100 Hz frequency. The bath temperature within 10 to 40 °C range was found to have negligible effect on the amount of deposited cobalt as well as on the uniformity of depositions.

In order to visualize the uniformity of Co nws growth by AC deposition, cross-sections of the alumina templates were investigated using field emission scanning electron microscopy (FESEM). Figures 2(a)–2(c) show the arrangement of Co nws deposited inside the pores of sulfuric acid alumina templates at the same AC frequency (50 Hz) and peak-to-peak voltage ($U_{p-p}$) during 5, 15, and 60 minutes, respectively. The obtained data show quite uniform growth of Co nws from the bottom of almost all pores only at the onset of the process. The pores filling rate depends on AC voltage and of the pores diameter $\Phi_{pore}$. In case of sulfuric acid alumina templates formed at 25 V ($\Phi_{pore}$ 25–30 nm after pore widening), the uniform growth corresponds to a filling rate $v_{Co} \sim 6$ μm/h for the first 10 minutes of deposition at a constant $U_{p-p}$ of 32 V. Processing further, $v_{Co}$ decreases due to an increase in the template resistance, causing a reduced AC current. A smaller $\Phi_{pore}$ results in a faster growth of cobalt nws under the same AC treatment conditions. For example, $v_{Co} \sim 9.3$ μm/h was detected at $U_{p-p}$ of 32 V for alumina templates with average $\Phi_{pore}$ of 15 nm. It can be observed from Figure 2(b) that some cobalt nws grew faster than nws front. For prolonged AC treatment,
Figure 7: Top view SEM images of Co nw arrays after dissolution of oxalic acid alumina template (a, b) in part and (c) fully. Template fabrication: anodizing 3 hours; $U_{anod} 5.0 \, \text{V}$; $t_\text{anod} 30 \, \text{minutes in 0.5 M H}_3\text{PO}_4$. Following the detachment of alumina from the substrate and a back-side evaporation of a Cr/Au layer, the deposition of Co was conducted in the solution: 0.45 cos O$_3$, 0.7 M H$_2$BO$_3$, and TEA up to pH 5.7 at a constant DC current density of 0.12 mA cm$^{-2}$ for 5 hours.

this progressively leads to the formation of more and more uneven lengths of Co nwS emerging onto the template surface in cobalt caps (see Figure 2(c)). We suggest that at least two reasons can be linked with the retarded growth of Co nwS: (i) gas burbles formation resulting in the plug of some pores and nonuniform current density from pore-to-pore due to nonuniform resistance of alumina barrier layer.

The nwS height uniformity was found to be independent on the $f$.

Typical morphology of cobalt nw arrays assembled inside the sulfuric acid alumina pores by short-term AC deposition after the template etching is presented in Figure 3. As seen, in cases of 1-2 $\mu$m length of Co nwS they are densely packed and quite uniform in length.

3.3. AC and DC Deposition through a Reconstructed Barrier Layer. The key feature of AC deposition process of the densely packed Co nwS is that only sulfuric acid alumina templates can be successfully applied. Fabrication of Co nwS in the nanochannels of alumina template formed in the oxalic or phosphoric acid anodizing baths, however, is problematic for AC deposition. One possible explanation for this effect is the adsorption and incorporation of acid anions at some depth of the alumina barrier layer, changing the state of alumina/solution interface at the bottom of pores (surface charge, free energy, etc.) and preventing the discharge of Co$^{2+}$ ions. Besides, highly ordered oxalic and phosphoric acid alumina templates are usually formed at higher voltages [6, 33, 34] and, therefore, present much thicker barrier layers at the metal/oxide interface. To use these templates for AC deposition of various materials, the step-wise voltage decreasing at the end of anodizing process has been proposed [17] and successfully used in several works. We found herein that this is helpful also for the Co case, however, only for short-time processing. The Co nwS array produced by long AC treatment, that is, longer than 15 minutes, viewed in the template cross-sections after the dissolution of some part of template, clearly show nonuniform growth from pore to pore and the formation of mushroomed Co fragments (Figure 4) outgrowing from the breakdown sites of the alumina barrier layer. The modification of alumina barrier layers through (i) the decreasing of anodizing voltage ($U_{anod}$) at the end of oxalic acid alumina growth down within 13 to 5 V, (ii) the
cathodic treatment in the same anodizing bath for 3 minutes at various potentials, and (iii) the chemical etching in the solution of sulfuric acids inhibits the uniformity of the depositions (see Figure 5). The most uniform alumina color was obtained after decreasing $U_a$ and chemical etching in the solution of sulfuric acid. Nevertheless, in this case the SEM cross-sectional observations of templates revealed the formation of Co $n w s$ tufts in random areas of template (Figure 6(a)). It is worth to note that these tufts were found to arise from cobalt balls (Figures 5(b), 6(b)–6(d)) formed at the metal/template interface. It is clear that the formation of metallic Co balls started below the pores in places where the barrier layer damage takes place. Therefore, the current strength in such places ought to increase drastically. So, we suggest that under these conditions except the spontaneous Co $n w s$ bundles growth, the electrochemical etching of aluminium and the formation of Co balls proceed.

Time and potential variables in the cathodic pre-treatment of the oxalic acid templates in the anodizing bath as well as variations of the deposition potential were found to be ineffective for uniform, rod-like Co formation by $A C$ deposition through the remained barrier layer. Note that in case of $D C$ depositions through the remained barrier layer at constant potential, the detachment of alumina template from the substrate proceeds just after several minutes of such treatment independently on the value of potential applied.

3.4. Galvanostatic Deposition. An alternative approach for Co $n w s$ deposition was examined for oxalic acid alumina templates by $D C$ galvanostatic deposition, after removing or opening the barrier layer on the pores bottom. In this setup, we used either an electrochemical/chemical method for the barrier layer perforation, or we detached the alumina from the substrate, removed the barrier layer, and made a subsequent evaporation of Cr/Au layer, acting as a conducting pad. The resulting Co $n w s$ released from the as-filled templates are shown in images 7(a), 7(b), and 7(c) of Figure 7. We found here that by applying a low current density during the entire deposition process, ca. $< 0.2 \text{mA cm}^{-2}$, well-ordered, densely packed, continuous, and highly aligned Co $n w s$ arrays, faithfully reproducing the shape of the pores and with height up to several tens of micrometers, can be synthesized by this way. Furthermore, after alumina dissolution these $n w s$ seem not to collapse and stuck together, as in the case of $A C$ synthesis, implying an easier application in future nanoelectronics and novel efficient sensors.

A typical XRD profile of a template filled with Co $n w s$ via $D C$ galvanostatic deposition at $0.12 \text{mA cm}^{-2}$ for 5 hours is shown in Figure 8. Only a single peak is observable at $2\Theta = 41.59$. According to the XRD library patterns for bulk Co (PDF 89-4308), this peak corresponds to the (100) reflection of the hexagonal closely packed Co lattice. Further, some additional weak signals situated at $2\Theta = 47.39$ and $2\Theta = 75.89$, ascribed to hexagonal Co phase in (101) and (110) directions, respectively, can be observed. These weak features inferred that Co $n w s$ are not single crystals but consist of oriented polycrystals with a preferred (100) growth direction perpendicular to the substrate. We note that the preferential growth of hexagonal Co phase in (100) direction is not a trivial case and differs from the growth of Co $n w s$ inside the alumina pores via $A C$ and potentiostatic depositions reported recently in [35], where the formation of Co $n w s$ arrays with (110) orientation has been demonstrated.

4. Conclusions

In the present work, we show how different types of processing conditions influence the quality and phase composition of Co $n w s$ deposited inside the sulphuric and oxalic acid alumina templates. In this context, a suitable method for the fabrication of densely packed, perfectly aligned Co $n w s$, with high aspect ratio, within the oxalic acid alumina pores, was found. Moreover, we showed that Co $n w s$ deposited inside the alumina pores under $D C$ galvanostatic mode consist of oriented polycrystals of hexagonal cobalt with a preferred (100) growth direction, that is not trivial case. The synthesis procedure described above allows a long-term $D C$ galvanostatic deposition, at low current density in optimized Co$^{2+}$-containing solution, and is based on the formation of template by Al anodizing, reanodizing at decreased voltage, detachment from the substrate, chemical etching for the perforation of alumina barrier layer at the bottom of pores and a one-side evaporation of a Cr/Au layer for ohmic contact. Important issues such as growth rate, phase composition, uniformity and continuity of encapsulated Co $n w s$ as a function of applied deposition methods have been also presented.

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